

Title (en)

METHOD AND APPARATUS FOR SAMPLING A PLASMA INTO A VACUUM CHAMBER

Publication

EP 0112004 A3 19851106 (EN)

Application

EP 83306372 A 19831020

Priority

CA 417227 A 19821208

Abstract (en)

[origin: EP0112004A2] A plasma (24) is generated within an induction coil (12) and the plasma is sampled through an orifice (30) into a vacuum chamber (28) for mass analysis of trace ions in the plasma. Arcing at the orifice is prevented by grounding the induction coil at or near its centre, thus eliminating ultra-violet noise and reducing average ion energies and ion energy spread, as well as preventing destruction of the orifice. The elimination of arcing at the orifice allows the use of a sharp edge orifice structure (92) to prevent formation of a cool boundary layer over the orifice and also permits direct sampling of the plasma. The direct sampling and the lack of cooling prevent recombination and reaction of the ions with oxygen and improve the response to elements of high ionization potential, increasing the desired ion signal and greatly reducing the presence of oxides which would otherwise complicate the spectrum.

IPC 1-7

H01J 49/04

IPC 8 full level

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CPC (source: EP)

H01J 49/0422 (2013.01); **H01J 49/105** (2013.01); **H05H 1/46** (2013.01)

Citation (search report)

- [A] FR 1471211 A 19670303 - AQUITAINE PETROLE
- [A] US 2831134 A 19580415 - OTTO REIFENSCHWEILER

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